SHORT COURSE REGISTRATION FORM, Spring 2001

American Vacuum Society/New Mexico Chapter

Send Registration Forms and checks payable to AVS/NMC to:
Heidi Ruffner
Advanced Materials Laboratory
1001 University Blvd SE, Suite 100
Albuquerque, NM 87106
Phone/FAX (505) 296-3816

Name		
Company	E-mail	
Address		
		Zip
Telephone # _	FAX #	· · · · · · · · · · · · · · · · · · ·
Job Position _		
Student Schola	arship Applicant? Yes No	
Fees	Courses	Dates
\$1,295	A Basic Vacuum Technology	MonFri., May 21-25
\$525	B Plasma-Enhanced Chemical Vapor Deposition:	Mon., May 21
	Fundamentals, Techniques, & Applications	
\$525	C Vacuum Vessel Engineering	Mon., May 21
\$775	D Sputter Deposition	Mon. & Tues., May 21 & 22
\$525	E Mass Flow Controllers:	Tues., May 22
	Fundamentals, Techniques, and Applications	
\$775	F Operation and Maintenance of Vacuum Pumping Systems	Tues. & Wed., May 22 & 23
\$625	G An Introduction to Ellipsometry	Wed., May 23
\$525	H An Introduction to Ion Sources: Principles and Techniques	Thurs., May 24
\$525	I Chemical Mechanical Planarization for	Thurs., May 24
	Microelectronics Manufacturing	
\$525	J-1 Plasma Etching and Reactive Ion Etching: Fundamentals	Thurs., May 24
\$725	J-2 Plasma Etching and Reactive Ion Etching:	Thurs. & Fri., May 24 & 25
	Fundamentals & Applications	
\$525	K Microfabrication Technology for	Fri., May 25
	Micro-electromechanical Systems	
\$525	L Vacuum Leak Detection	Fri., May 25
<u>\$</u>	TOTAL AMOUNT DUE	
Payment by:	Check Visa Master	
Card Credit Card # Expiration		date:
Signature autho	rizing use of credit card	

All classes meet from 8:30 AM - 4:30 PM at the Wyndham Hotel, 2910 Yale Blvd., SE, Albuquerque, New Mexico